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## **Review Article**

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# **Actuator for Nano Engineering Research and Development**

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#### **Abstract**

We obtained the parameters of the actuator for nano engineering research and development. The structural diagram and the parameters of the actuator at the piezoelectric or magnetostrictive effect for nano engineering are determined.

**Keywords:** Actuator, Nano Engineering, Piezo Actuator, Characteristic, Parameter.

### Introduction

Actuator for nano engineering research and development is used to nano manipulations in the scanning microscope, the nano pump, the gene manipulator, the cell penetration tool, the micro surgery [1-16].

We obtain the transfer functions and the characteristics of the actuators on the piezoelectric and magnetostrictive effect for control system of the nano deformation for nano engineering research and development [17-32].

## **Structural Diagram**

The equation of electro magneto mechanics for relative deformation  $S_i$  of the piezoelectric or magnetostrictive actuator has the form [8, 11].

$$S_i = \mathbf{v}_{mi} \mathbf{\Psi}_m + s_{ij}^{\Psi} T_j$$

where  $v_{mi}$ ,  $\Psi_m$ ,  $s_{ij}^{\Psi}$ ,  $T_j$  are the module, the control parameter, the elastic compliance, the mechanical stress, and i, j, m are the indexes.

The second order differential equation for the actuator has the form [8, 12, 14].

$$\frac{d^2\Xi(x,p)}{dx^2} - \gamma^2\Xi(x,p) = 0$$

where  $\Xi(x,p)$  is the Laplace transform of the displacement, x, p,  $\gamma$  are the coordinate, the operator, the propagation coefficient. The matrix equation is obtained with using the equation of electro magneto mechanics, the differential equation and its boundary conditions in the form

$$(\Xi(p)) = (W(p))(P(p))$$

where  $(\Xi(p))$  is the matrix of the transforms of the displacements for its two faces of the actuator, (W(p)) is the matrix transfer function, (P(p)) is the matrix of the transforms of the control parameter of the actuator and the forces for two faces.

The mathematical model and the structural diagram on Figure 1 of the actuator are obtained from decision the equation of electro magneto mechanics and its differential equation [12-16]. In result the mathematical model of the actuator for nano engineering research and development has the form

$$\begin{split} &\Xi_{1}(p) = \left[1/\left(M_{1}p^{2}\right)\right] \times \\ &\left\{-F_{1}(p) + \left(1/\chi_{ij}^{\Psi}\right)\left[\begin{matrix} v_{mi}\Psi_{m}(p) - \left[\gamma/\sinh(l\gamma)\right] \\ \times \left[\cosh(l\gamma)\Xi_{1}(p) - \Xi_{2}(p)\right] \end{matrix}\right]\right\} \\ &\Xi_{2}(p) = \left[1/\left(M_{2}p^{2}\right)\right] \times \\ &\left\{-F_{2}(p) + \left(1/\chi_{ij}^{\Psi}\right)\left[\begin{matrix} v_{mi}\Psi_{m}(p) - \left[\gamma/\sinh(l\gamma)\right] \\ \times \left[\cosh(l\gamma)\Xi_{2}(p) - \Xi_{1}(p)\right] \end{matrix}\right]\right\} \end{split}$$

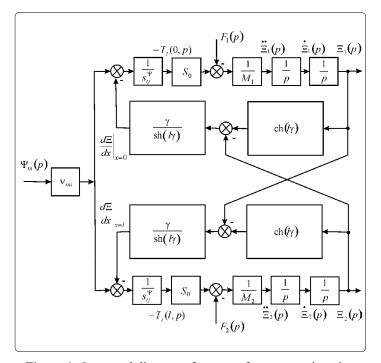
$$\chi_{ij}^{\Psi} = s_{ij}^{\Psi} / S_0$$
,  $v_{mi} = \begin{cases} d_{33}, d_{31}, d_{15} \\ d_{33}, d_{31}, d_{15} \end{cases}$ ,  $\Psi_m = \begin{cases} E_3, E_1 \\ H_3, H_1 \end{cases}$ ,

$$\begin{split} s_{ij}^{\Psi} &= \begin{cases} s_{33}^E, s_{11}^E, s_{55}^E \\ s_{33}^H, s_{11}^H, s_{55}^H, & E, H \text{ are the electric and magnetic fields} \end{cases} \\ \text{strengths, } \Xi_1(p), \ \Xi_2(p), \ F_1(p), F_2(p) \text{ are the transforms of the displacements and the forces of the faces for its two faces, } M_1, \\ M_2, \ l \text{ are the mass and the length.} \end{split}$$

The transfer function of the transverse piezo actuator with fixed one face has the form

$$W(p) = \frac{\Xi_2(p)}{U(p)} = \frac{k_{31}^U}{T_i^2 p^2 + 2T_i \xi_i p + 1}$$
$$k_{31}^U = (d_{31} l/\delta) / (1 + C_e / C_{11}^E), \ T_i = \sqrt{M_2 / (C_e + C_{11}^E)}$$

where  $k_{31}^U$  is the transfer coefficient for voltage,  $T_t$ ,  $\xi_t$  are the time constant and the damping coefficient of the actuator. At  $d_{31}$ =2·10<sup>-10</sup> m/V,  $h/\delta = 16$ , U = 50 V,  $M_2 = 4$  kg,  $C_{11}^E = 3 \cdot 10^7$  N/m,  $C_e = 0.3 \cdot 10^7$  N/m the parameters of the actuator from ceramic PZT are obtained in the form  $k_{31}^U = 2.91$  nm/V,  $\xi_2(\infty) = 145.5$  nm,  $T_t = 0.35 \cdot 10^{-3}$  s.



**Figure 1:** Structural diagram of actuator for nano engineering research and development research.

The characteristics of actuator are used in the calculation of nano mechatronics control systems for nano engineering research and development The relative deformation of actuator at elastic force has the form [7, 10-17, 20-31]

$$\frac{\Delta l}{l} = v_{mi} \Psi_m - \frac{s_{ij}^{\Psi} C_e}{S_0} \Delta l$$
$$F = C_e \Delta l$$

where l,  $\Delta l$ ,  $C_e$ ,  $S_0$  are the length, the displacement of the actuator, the stiffness of the load, the area of the actuator. The regulation characteristic of the actuator at elastic force has the form

$$\Delta l = \frac{\mathbf{v}_{mi} l \Psi_m}{1 + C_e / C_{ii}^{\Psi}}$$

$$C_{ii}^{\Psi} = S_0 / (s_{ii}^{\Psi} l)$$

where  $C_{ij}^{\Psi}$ , is stiffness of the actuator at  $\Psi = \text{const}$ .

Therefore, the regulation characteristic for the transverse piezo actuator for the elastic load has the form

$$\Delta l = \frac{(d_{31} l/\delta)U}{1 + C_e / C_{11}^E} = k_{31}^U U$$
$$k_{31}^U = (d_{31} l/\delta) / (1 + C_e / C_{11}^E)$$

where  $k_{31}^U$  is the transfer coefficient for voltage. For the piezo actuator from ceramic PZT at  $d_{31}$ =  $2 \cdot 10^{-10}$  m/V,  $l/\delta = 16$ ,  $C_{11}^E = 3 \cdot 10^7$  N/m,  $C_e = 0.3 \cdot 10^7$  N/m, U = 100 V the parameters of actuator are obtained in the form  $k_{31}^U = 2.91$  nm/V,  $\Delta l = 291$  nm.

The mechanical characteristic of the actuator has the form

$$\Delta l = \Delta l_{\text{max}} (1 - F/F_{\text{max}})$$
  
 $\Delta l_{\text{max}} = d_{31}E_{3}l , F_{\text{max}} = d_{31}E_{3}S_{0}/s_{11}^{E}$ 

where  $\Delta l_{\rm max}$  is the maximum displacement for F=0 and  $F_{\rm max}$  is the maximum force for  $\Delta l=0$ . At  $d_{31}=2\cdot 10^{-10}$  m/V,  $E_3=U/\delta=3\cdot 10^5$  V/m,  $l=2\cdot 10^{-2}$  m,  $S_0=1\cdot 10^{-5}$  m<sup>2</sup>,  $S_{11}^E=15\cdot 10^{-12}$  m<sup>2</sup>/N the parameters are received in the form  $\Delta l_{\rm max}=1200$  nm and  $F_{\rm max}=40$  N for the mechanical characteristic of the actuator from ceramic PZT.

### **Conclusions**

The structural diagram and the parameters of the actuator are obtained for the control system in nano engineering research and development.

The mathematical model of the actuator is written from decision the equation of electro magneto mechanics and the differential equation and its boundary conditions.

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